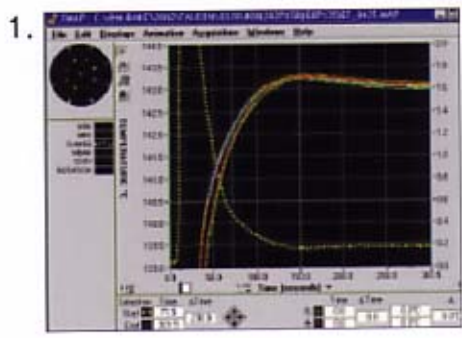




# Flat plate heat pipe for hot plate

1. Temperature change as a function of time after wafer loading



2. Temperature map on the wafer surface at the steady state

